

Application No.	Applicant(s)	
09/939,754	MCTIGUE ET AL.	
Examiner	Art Unit	
Young J. Kim	1637	

,					
SEARCHED					
Class	Subclass	Date	Examiner		
435	69.1	7/23/2004	YJK		
	183	7/23/2004	YJK		
514	44	7/23/2004	YJK		
530	402	7/23/2004	YJK		
536	23.1	7/23/2004	YJK		
		·			

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
435	69.1/183	7/23/2004	YJK		
514	44	7/23/2004	YJK		
530`	402	7/23/2004	YJK		
536/	23.1	7/23/2004	YJK		

SEARCH NOT (INCLUDING SEARCH))
	DATE	EXMR
Patent Database (USPT, USPGP, EPO, JPO, DERWENT, IBM-TDB) and SEQ ID NO: 5	7/23/2004	YJK
See enclosed search strategy	7/23/2004	YJK
		-
	·	